

Examiner: R. R. Bueker



(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Gealy et al.

Application No.: 10/814,573

0/814,573 Confirmation No.: 6920

Filed: March 31, 2004 Art Unit: 1763

For: AMPOULES FOR PRODUCING A

REACTION GAS AND SYSTEMS FOR DEPOSITING MATERIALS ONTO MICROFEATURE WORKPIECES IN

REACTION CHAMBERS

INFORMATION DISCLOSURE STATEMENT (IDS)

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

A copy of each Non-U.S. Patent and each Non-Patent Literature article listed on the PTO/SB/08 is attached. A copy of the U.S. Patents listed on the PTO/SB/08 has not been provided. A full translation of the non-English language references marked by a check mark ($\sqrt{}$) is enclosed. An abstract is enclosed for all other non-English language

Application No.: 10/814,573 Docket No.: 108298765US

references. Applicant has not verified that the translation or abstract is an accurate representation of the teachings of the non-English reference, though, and reserves the right to demonstrate otherwise.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0665, under Order No. 108298765US.

Dated: April 11, 2005

Respectfully submitted,

David T. Dutcher

Registration No.: 51,638

PERKINS COIE LLP

P.O. Box 1247

Seattle, Washington 98111-1247

(206) 359-8000

(206) 359-7198 (Fax)

Attorney for Applicant



PTO/SB/92 (09-04)

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Application No. (if known): 10/814,573

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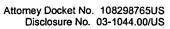
Transmittal Form (1 page) Information Disclosure Statement (2 pages)

Form PTO/SB/08 (13 pages) Cited References (64) Return Receipt Postcard

10/814,573-Conf. #6920

T	AL	Filing Date		March 31, 2004	
	FORM		First Named	Inventor	Dan Gealy
(to be used for all conespondence after initial filing)			Art Unit		1763
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Total Number	r of Pages in This Submis	sion 17*	Attorney Do	cket Numbe	108298765US
	EN	CLOSURES	(Check all	that appl	y)
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Firm Name)				
Signature	Dailde	til			
Printed name	David T. Dutcher				
Date April 11, 2005				Reg. No.	51,638

^{*} Number of pages does not include cited references



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				Application Number	10/814,573-Conf. #6920	
l	NFORMATI	ON DISC	LOSURE	Filing Date	March 31, 2004	
۱ :	STATEMEN	T BY AP	PLICANT	First Named Inventor	Dan Gealy	
	_			Art Unit	1763	
	(Use as many she ets as necessary)			Examiner Name	Richard R. Bueker	
Shee	1	of	13	Attorney Docket Number	108298765US	

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				Art Unit	1763	
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ST	ATEMENT BY APP	LICANT	First Named Inventor	Dan Gealy	
	///		Art Unit	1763	
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		Application Number 10/814,573—Conf. #6920		
INFORMATION DISCLO	DSURE	Filing Date	March 31, 2004	
STATEMENT BY APPL	ICANT	First Named Inventor	Dan Gealy	
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